

10/07/0070
02/15/02

IC 1120

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10076070	FILING DATE 02/15/2002	CLASS 096	SUBCLASS 122	GAU 122	EXAMINER Rodriguez
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****APPLICANTS:** Suzuki Nobuyasu; Yoshida Takehito; Makino Toshiharu; Yamada Yuka;

****CONTINUING DATA VERIFIED:**

W/A

**** FOREIGN APPLICATIONS VERIFIED:**
JAPAN 2001-37736 02/14/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO
35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	SUZUKI28
Verified and Acknowledged Examiners's initials		

TITLE : High-purity standard particles production apparatus and the same particles

U.S. DEPT. OF COMM. /PAT. & TM-PTO-436L (Rev. 12-94)

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NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL		Application Examiner	
DISCLAIMER		PREPARED FOR ISSUE	
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